

FIG. 1

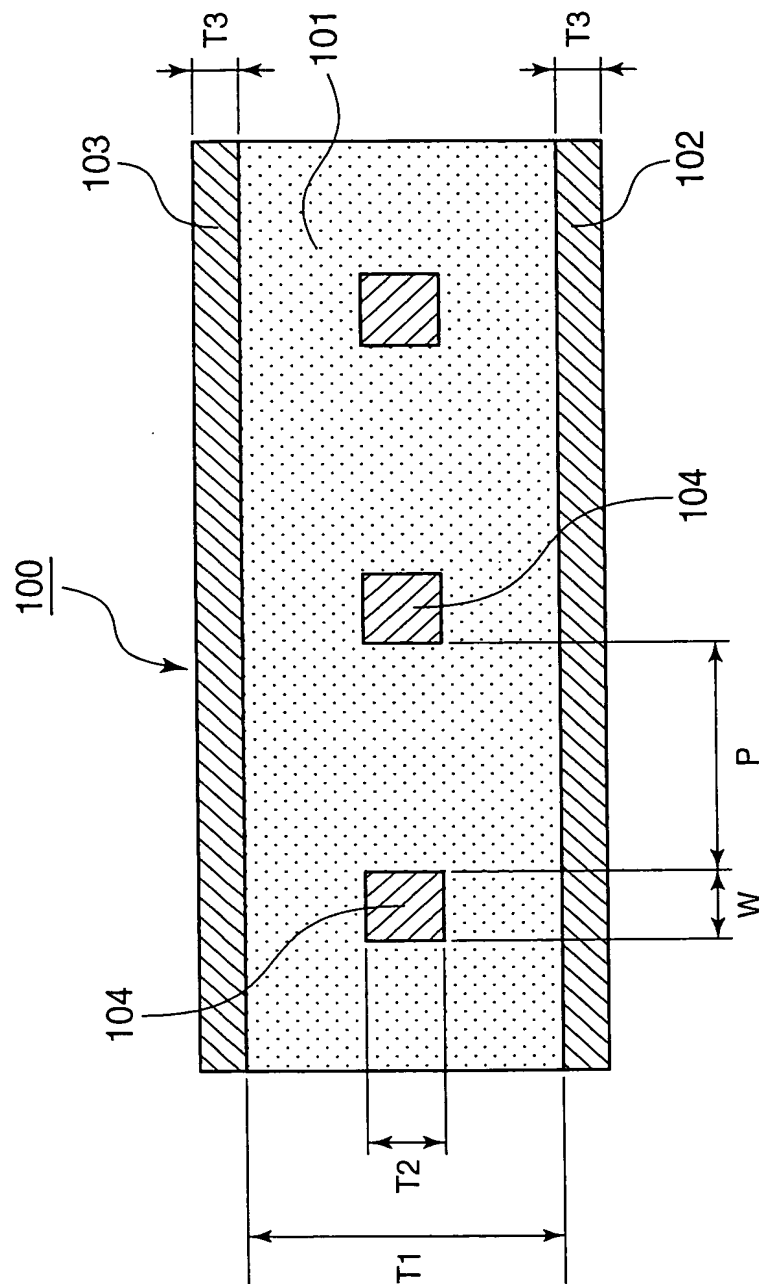


FIG. 2

FIG. 3A

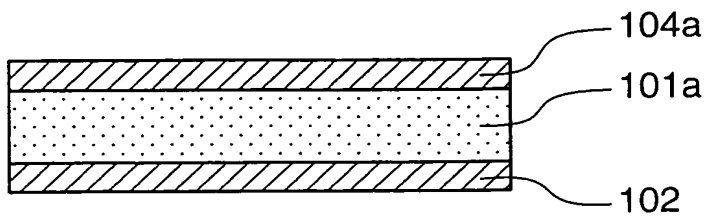


FIG. 3B

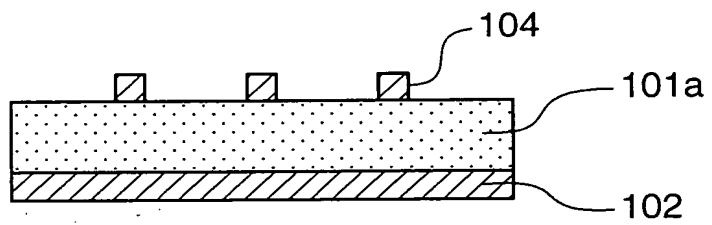


FIG. 3C

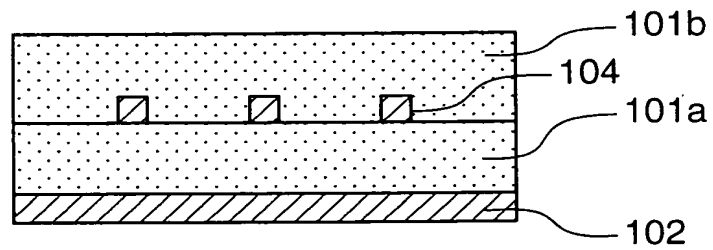
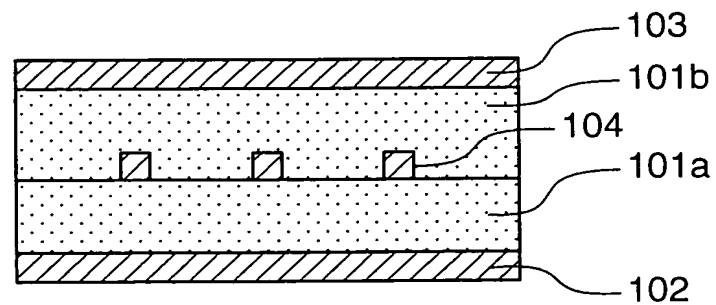


FIG. 3D



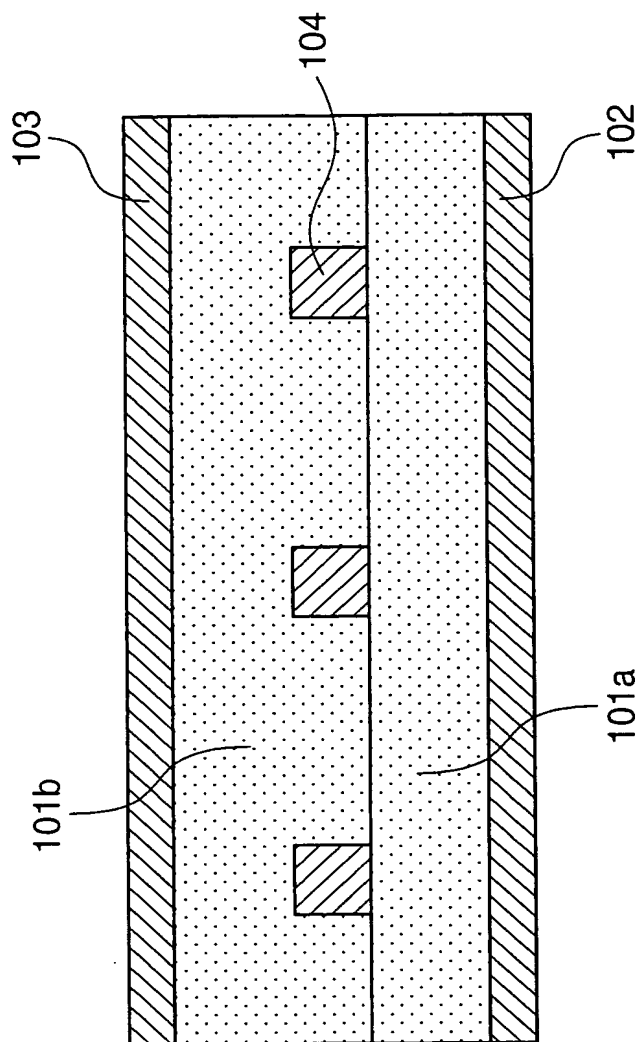


FIG. 4

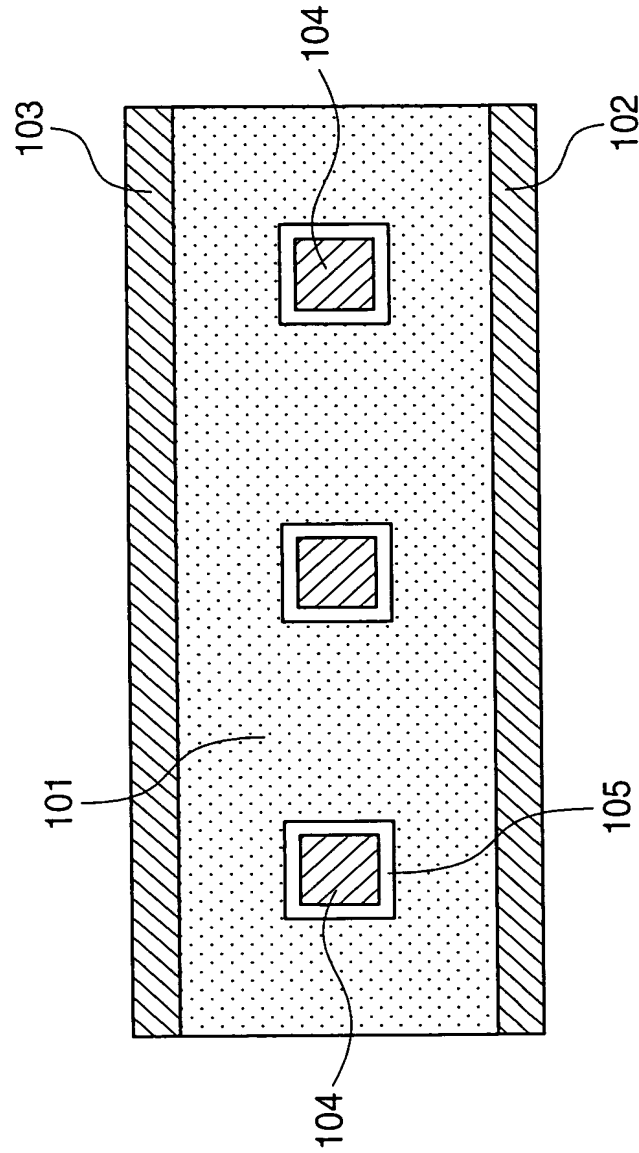


FIG. 5

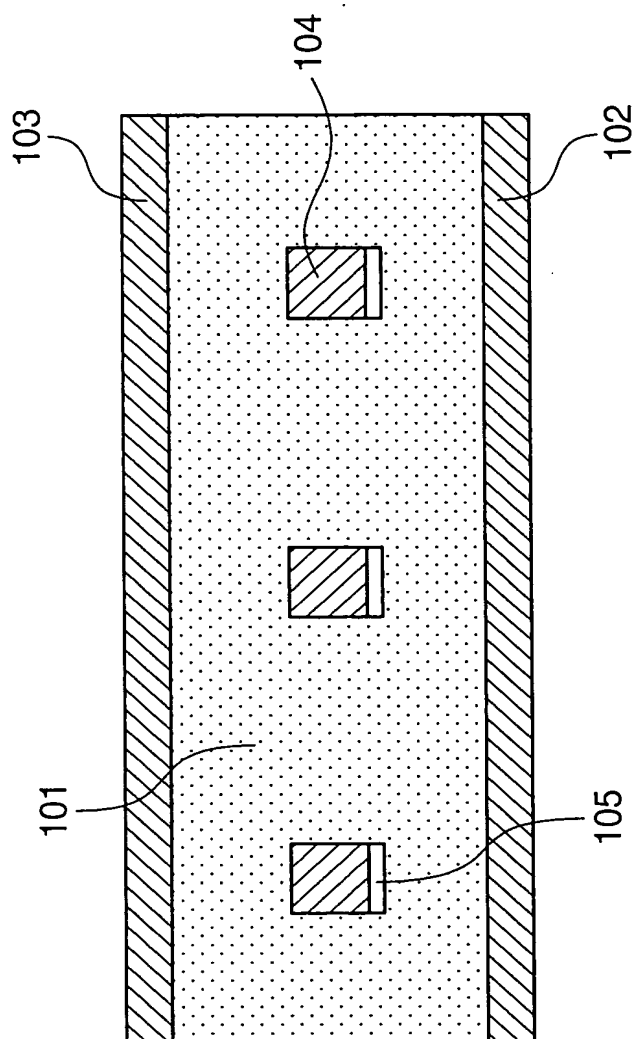


FIG. 6

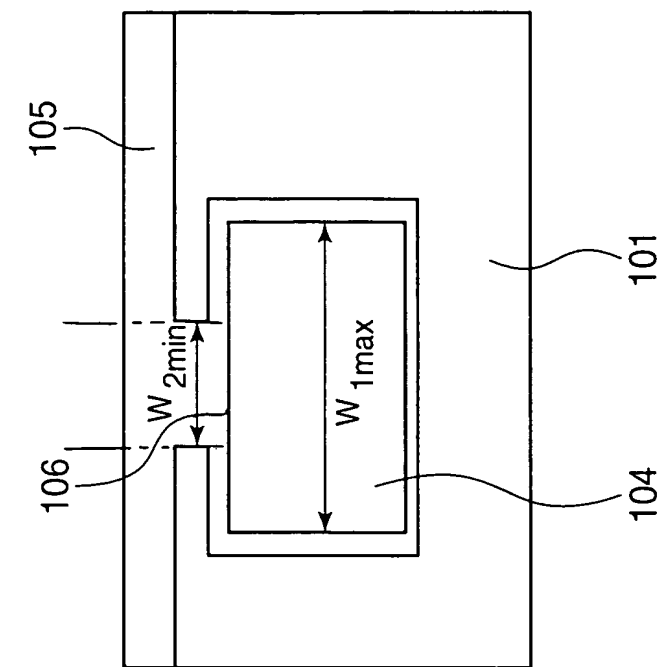


FIG. 7A

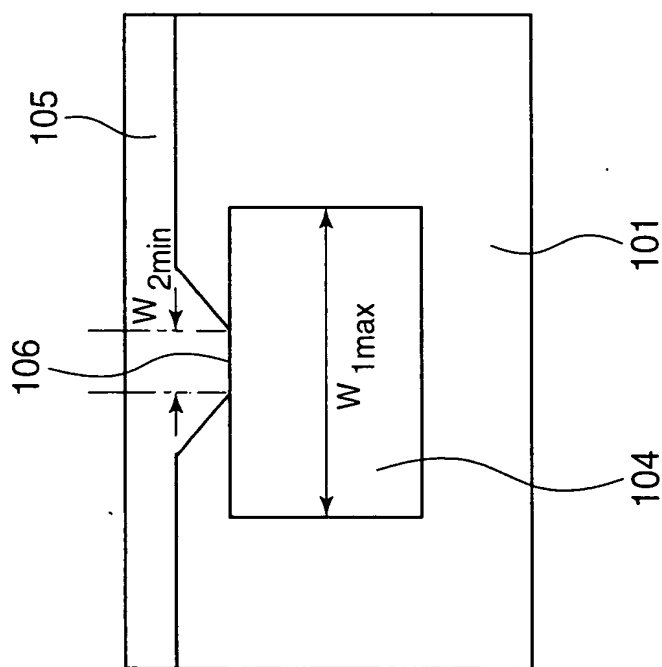


FIG. 7B

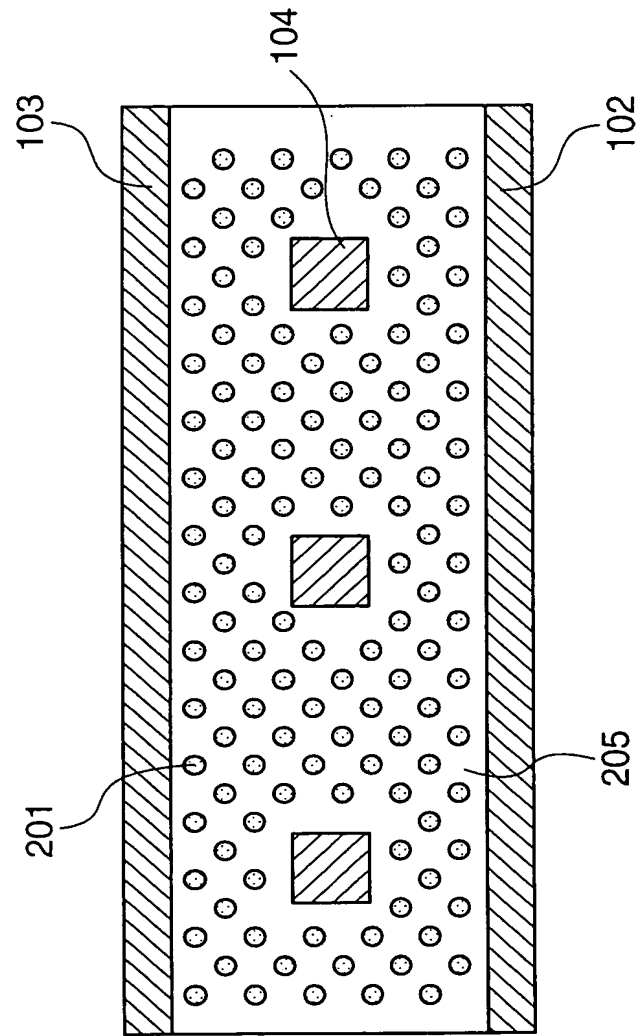


FIG. 8

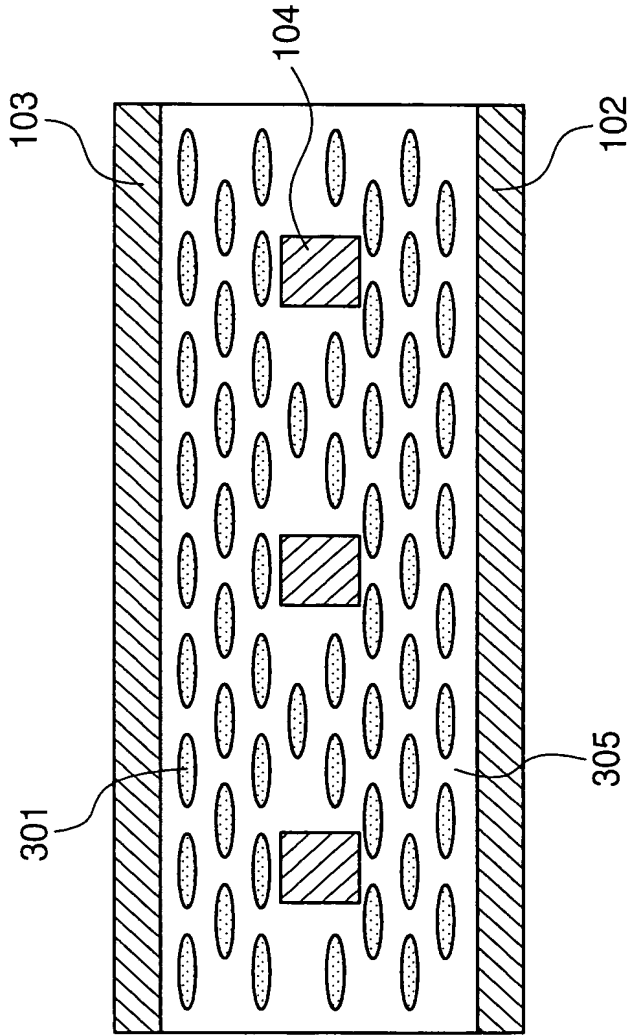


FIG. 9

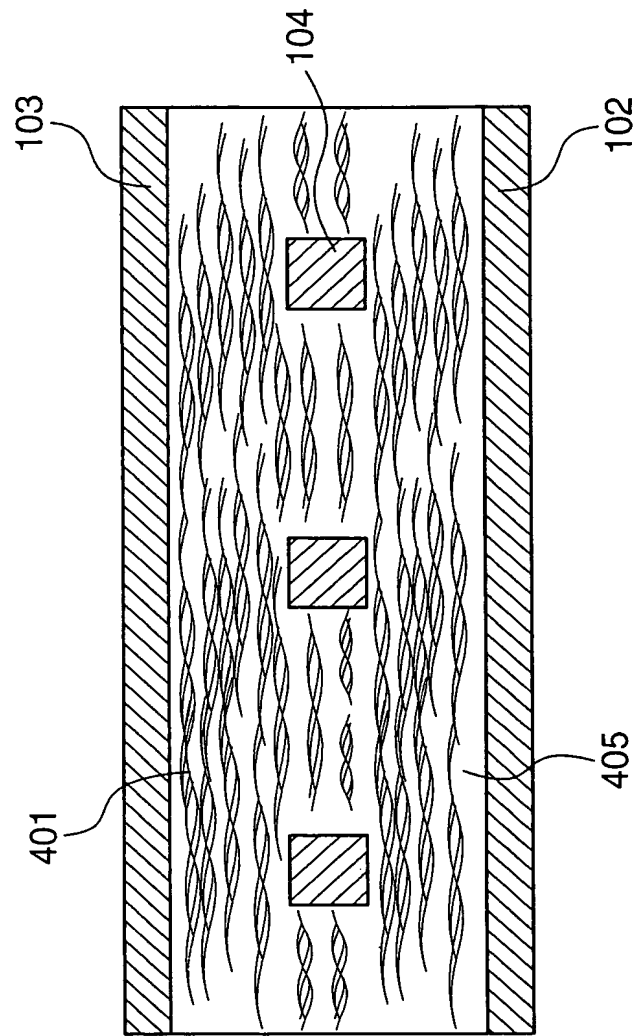


FIG. 10

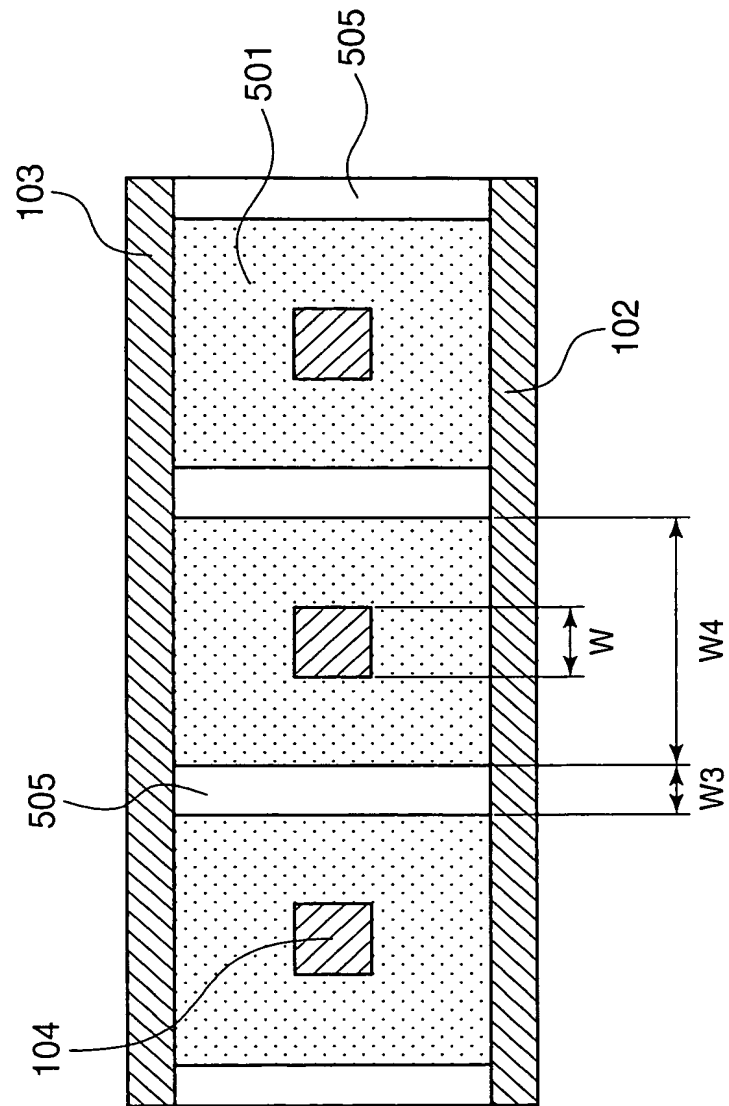


FIG. 11

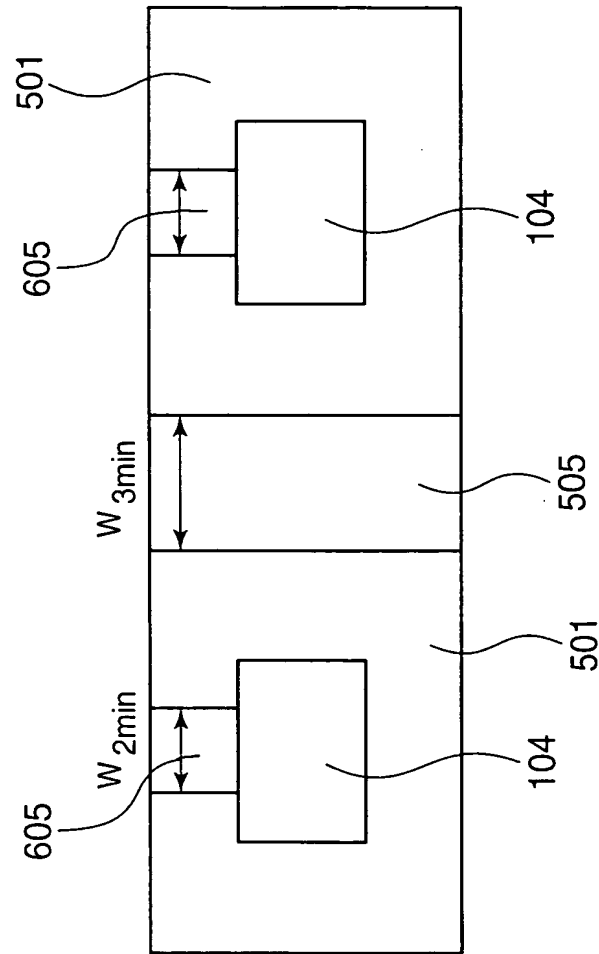


FIG. 12

FIG. 13A

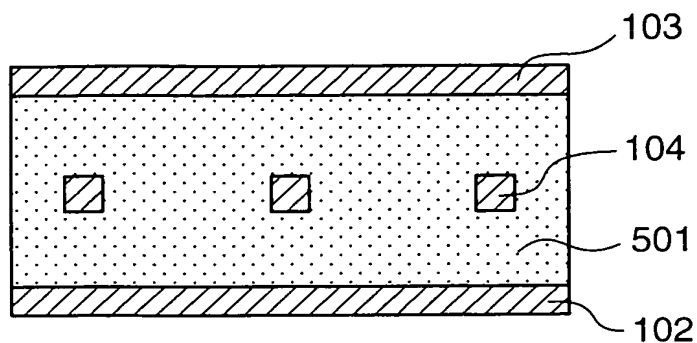


FIG. 13B

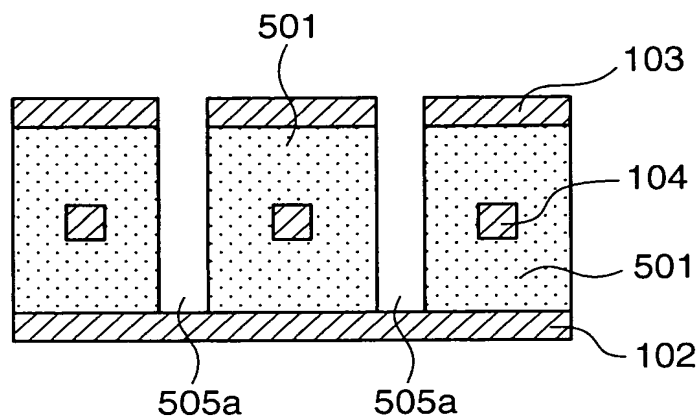
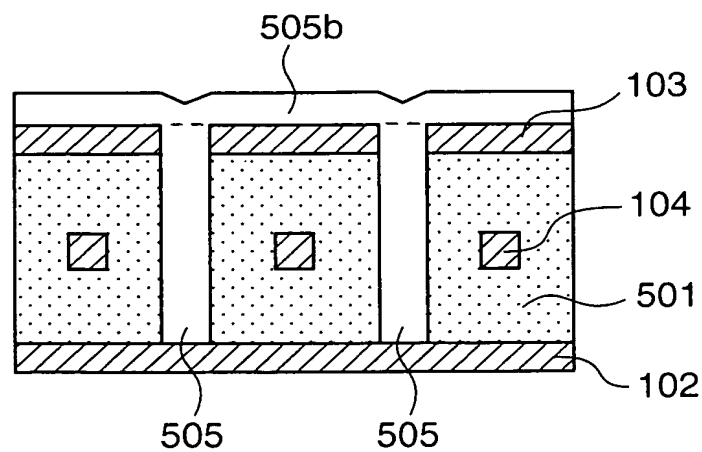


FIG. 13C



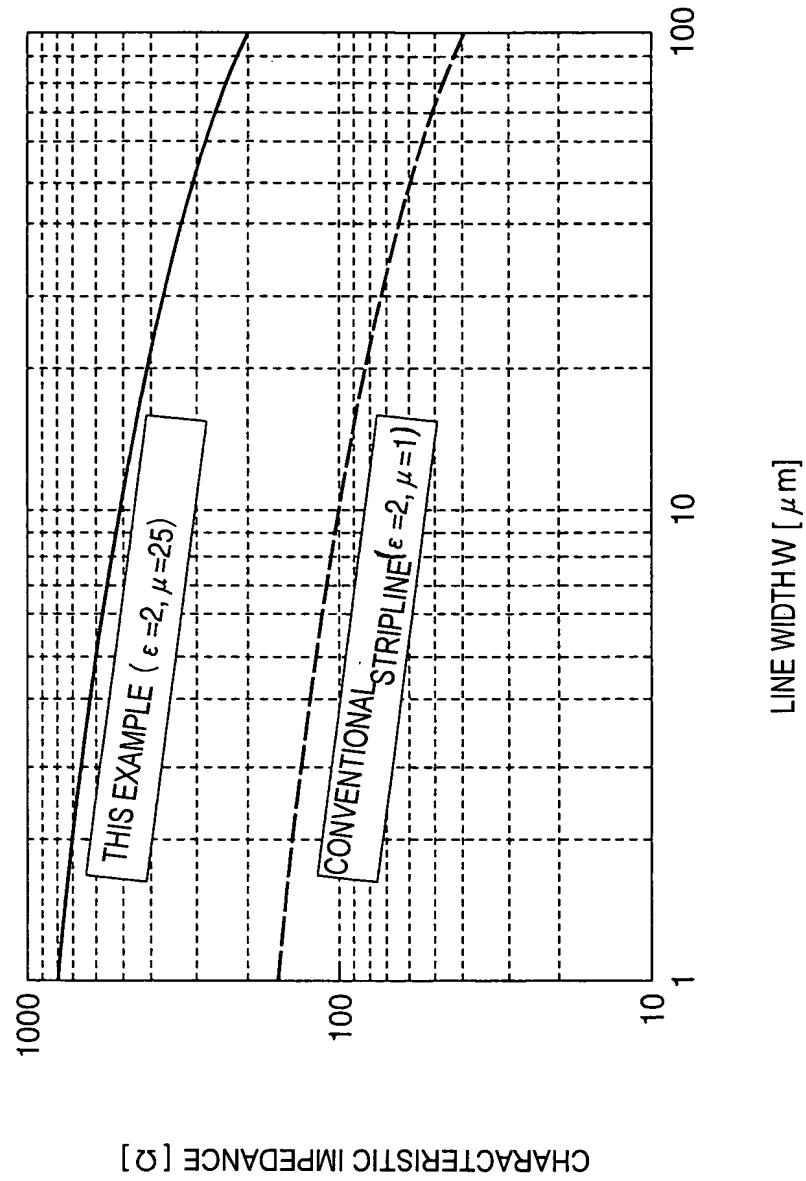


FIG. 14

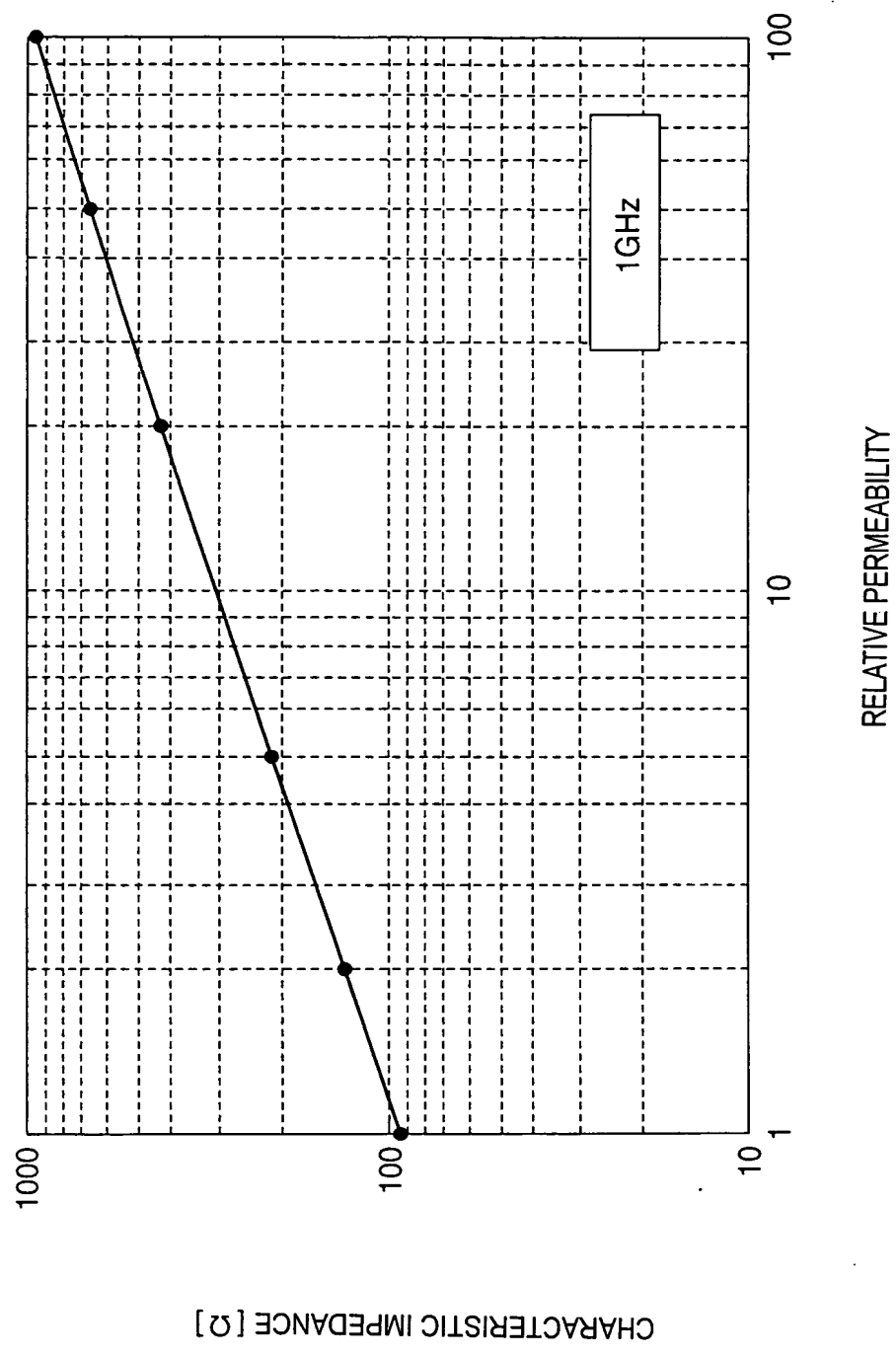


FIG. 15

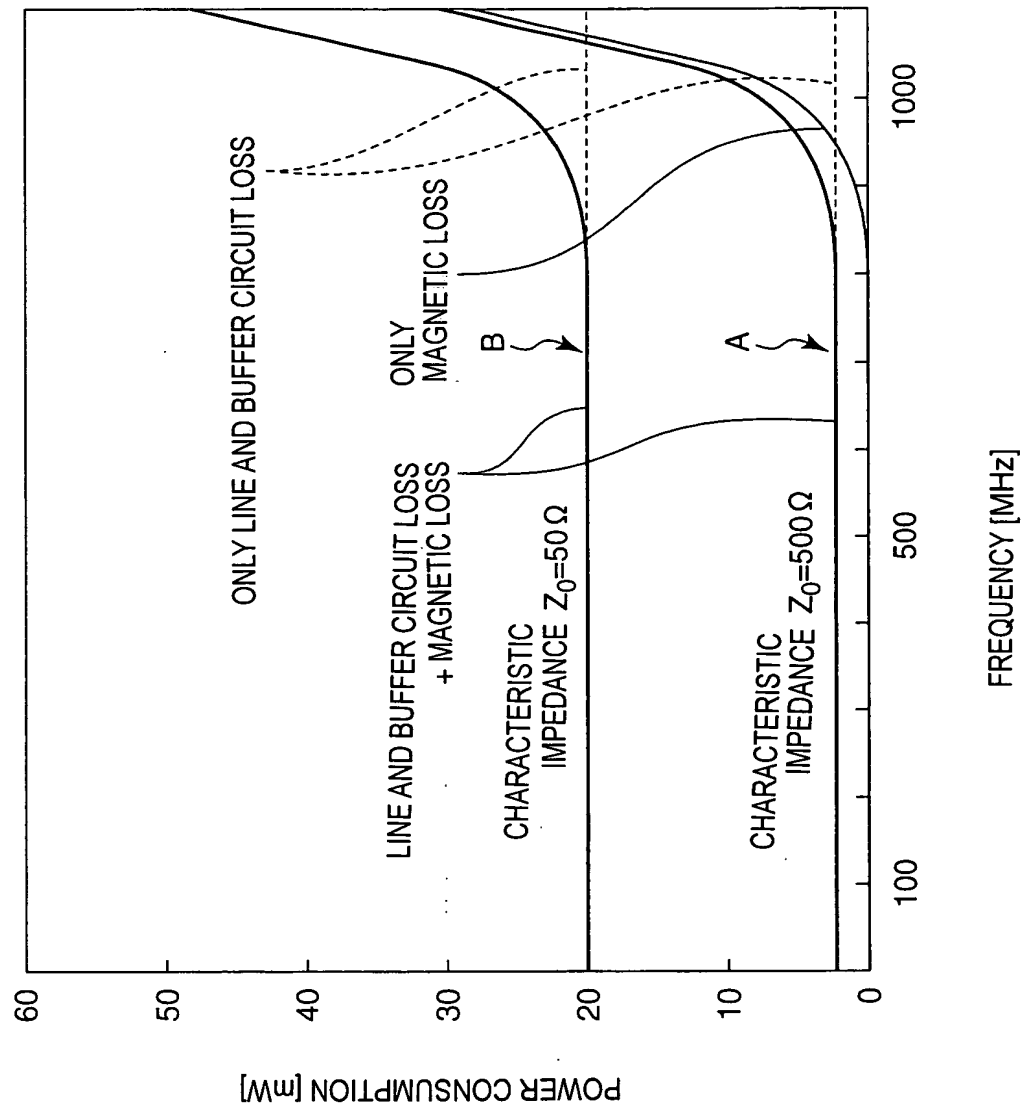


FIG. 16

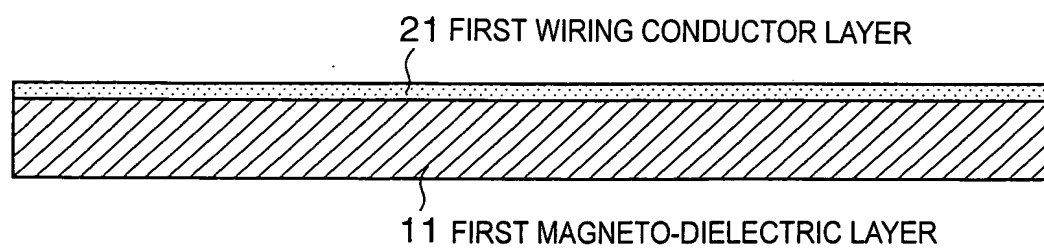


FIG. 17

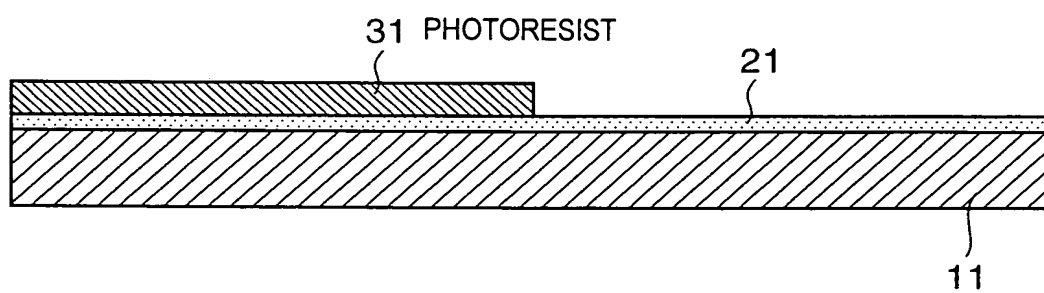


FIG. 18

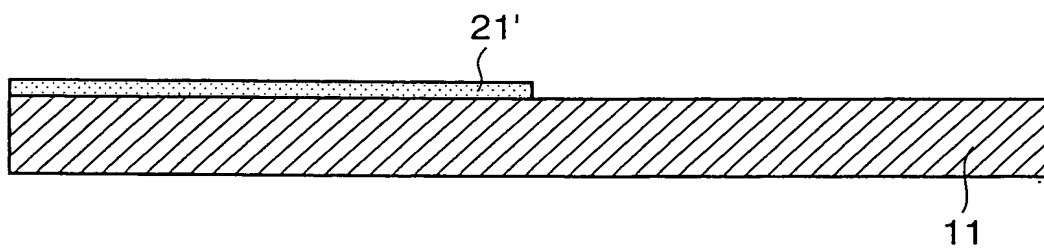


FIG. 19

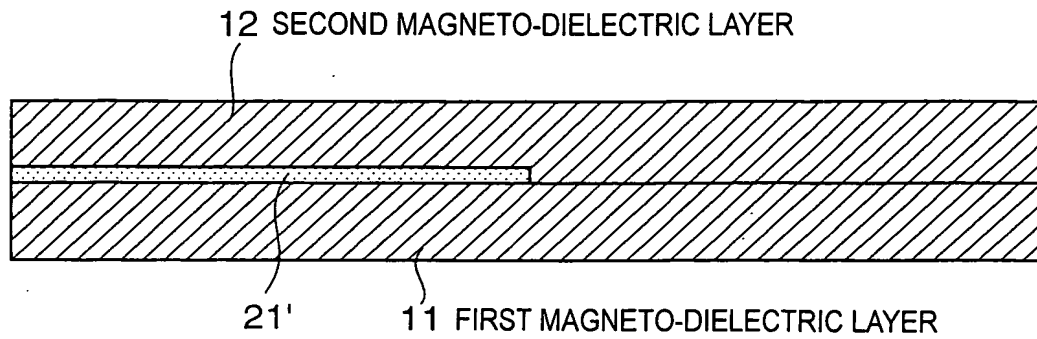


FIG. 20

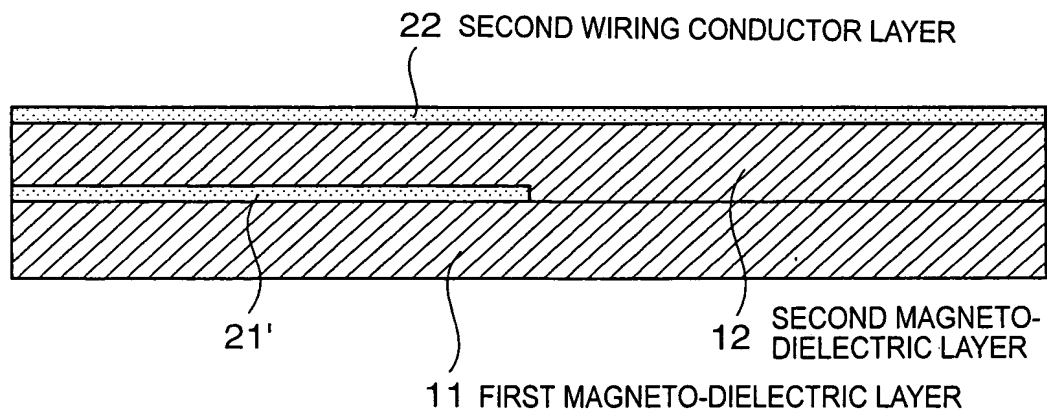


FIG. 21

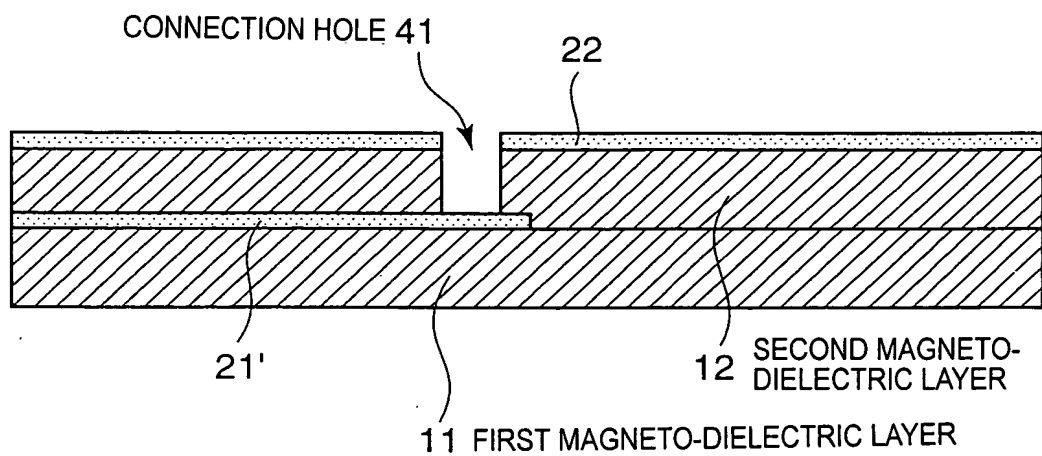


FIG. 22

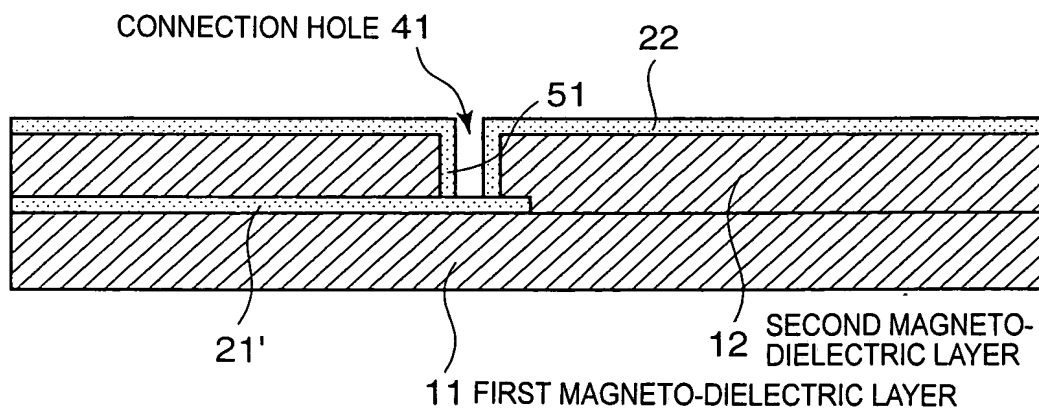


FIG. 23

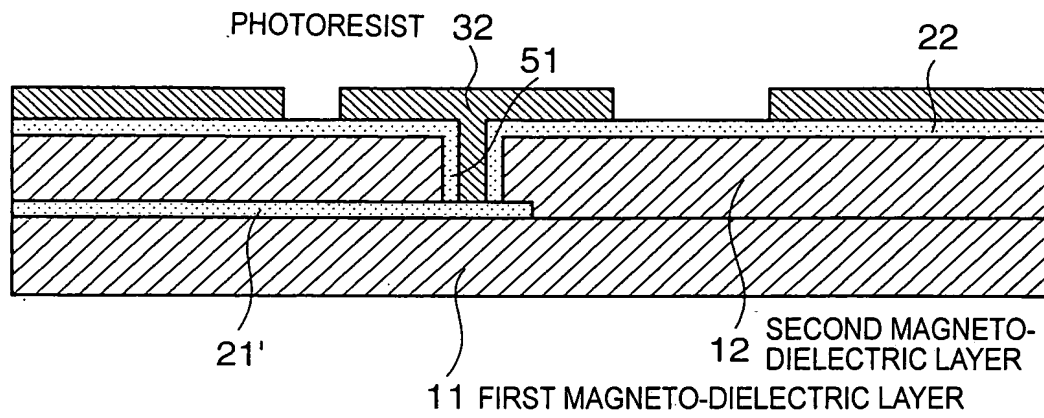


FIG. 24

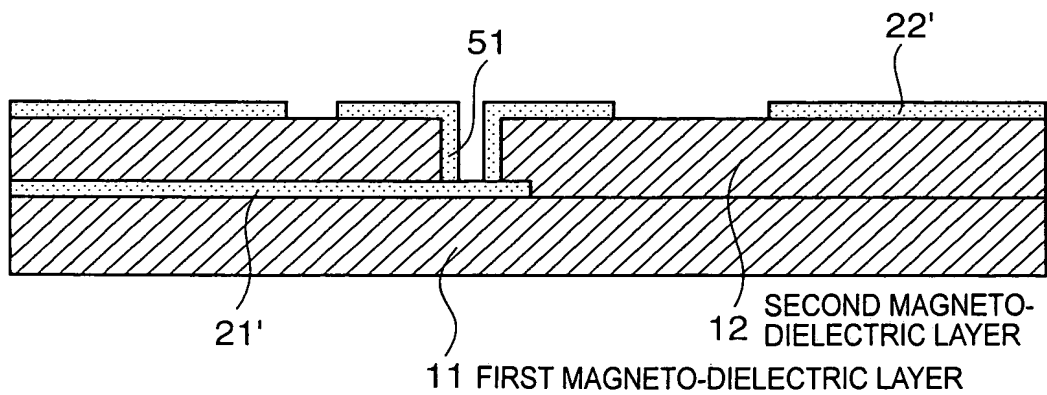


FIG. 25

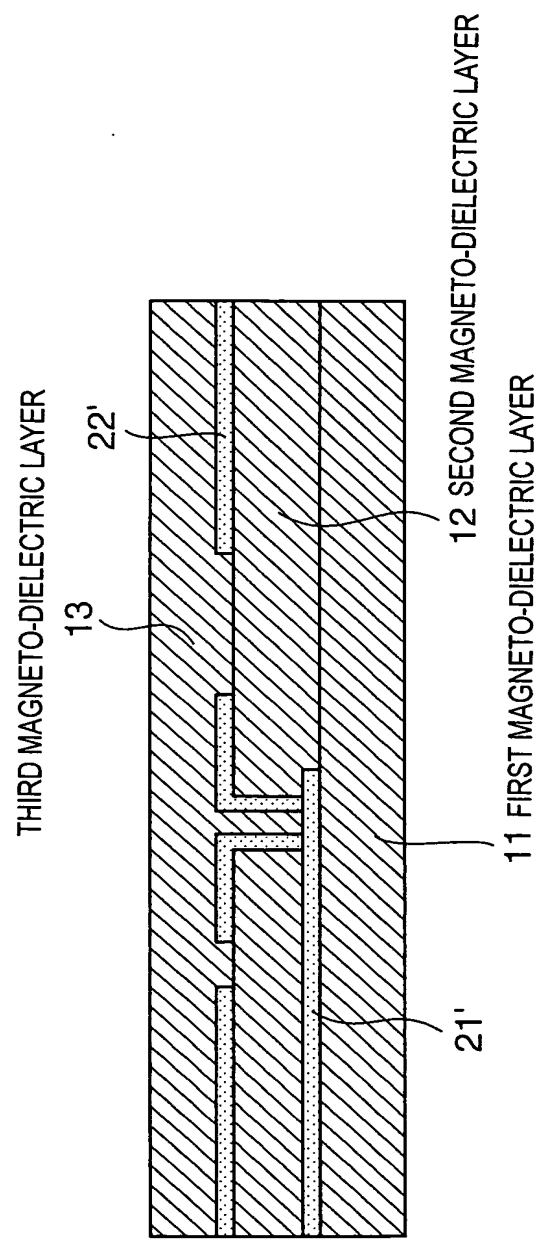


FIG. 26

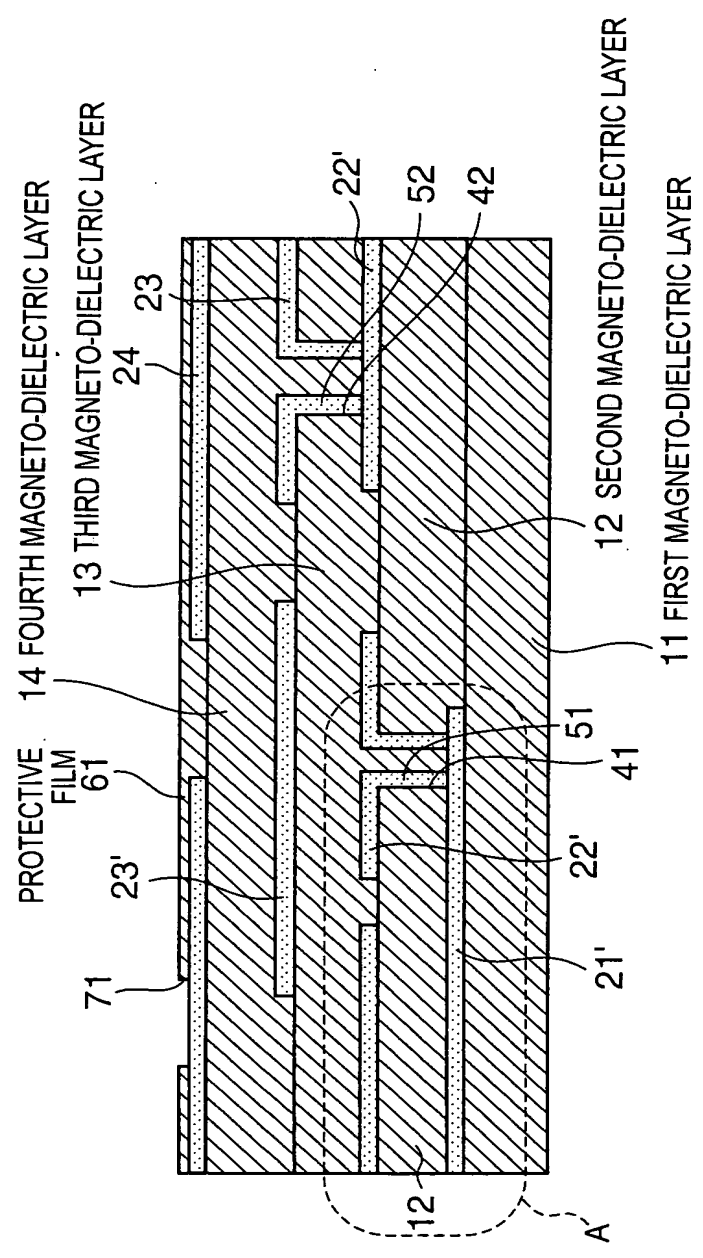


FIG. 27

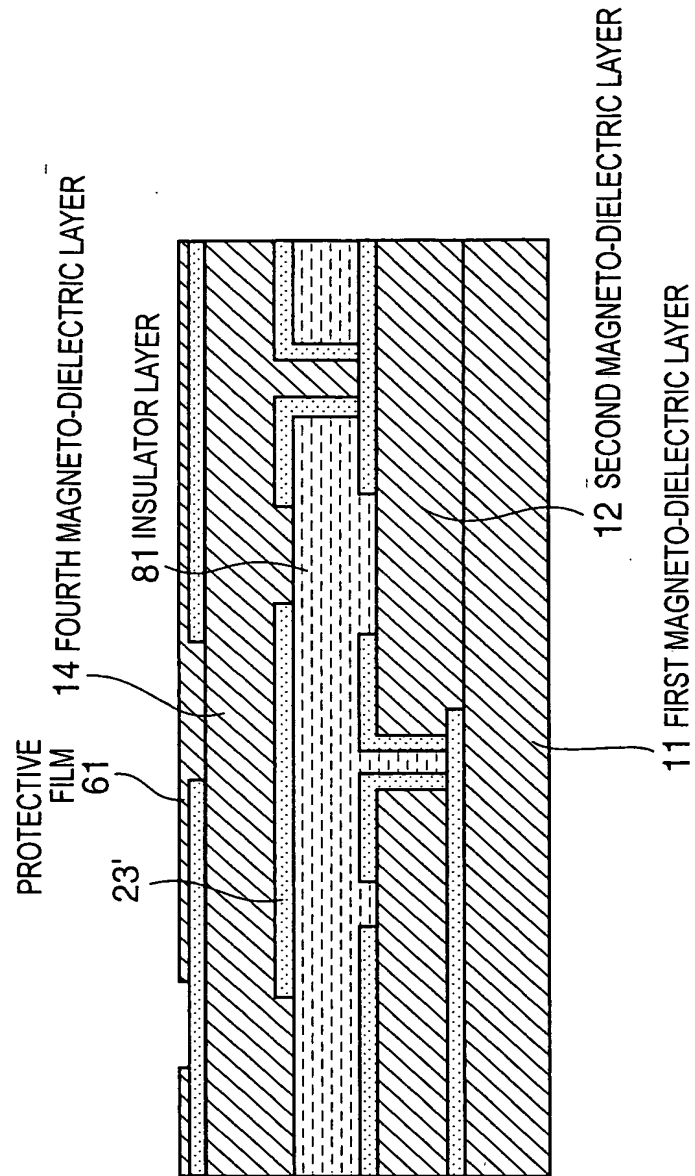


FIG. 28

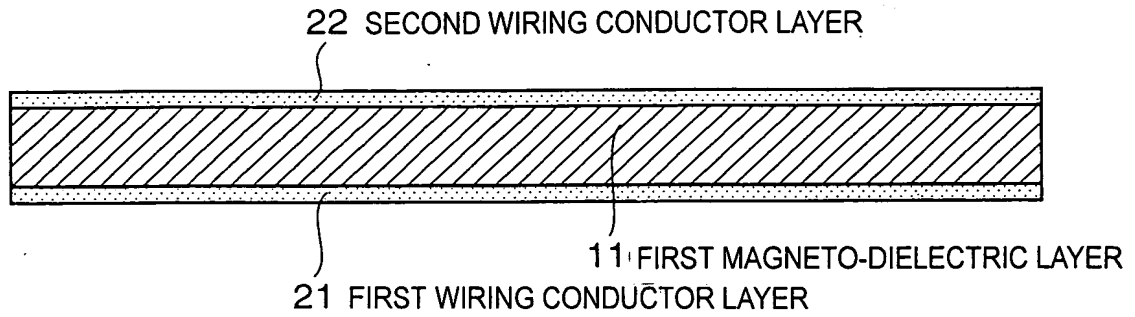


FIG. 29

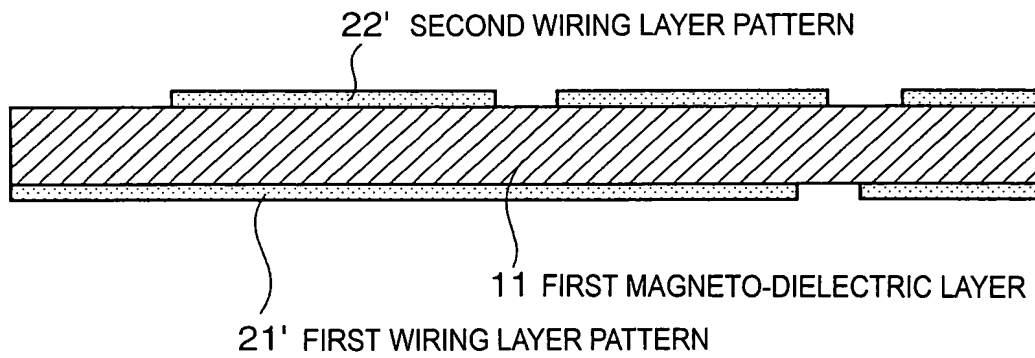


FIG. 30

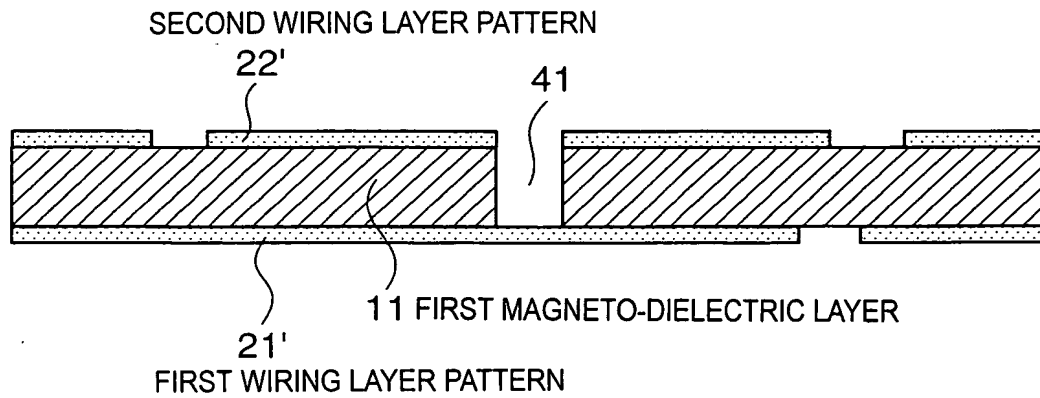


FIG. 31

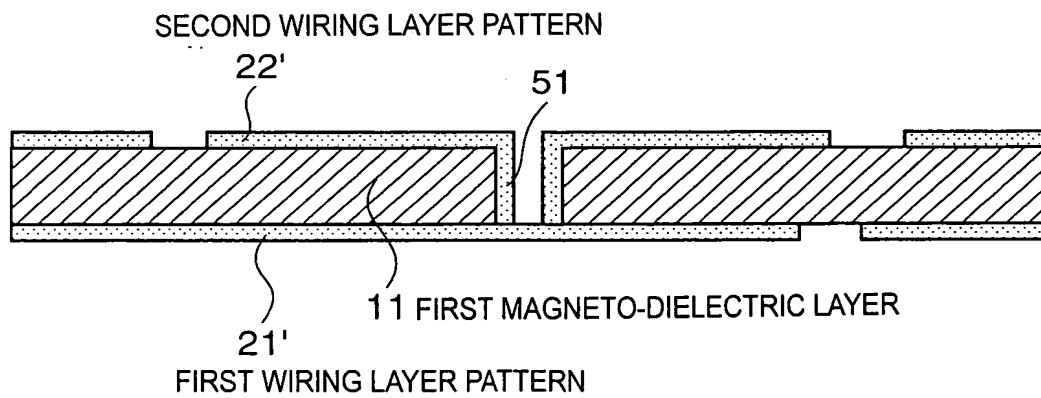
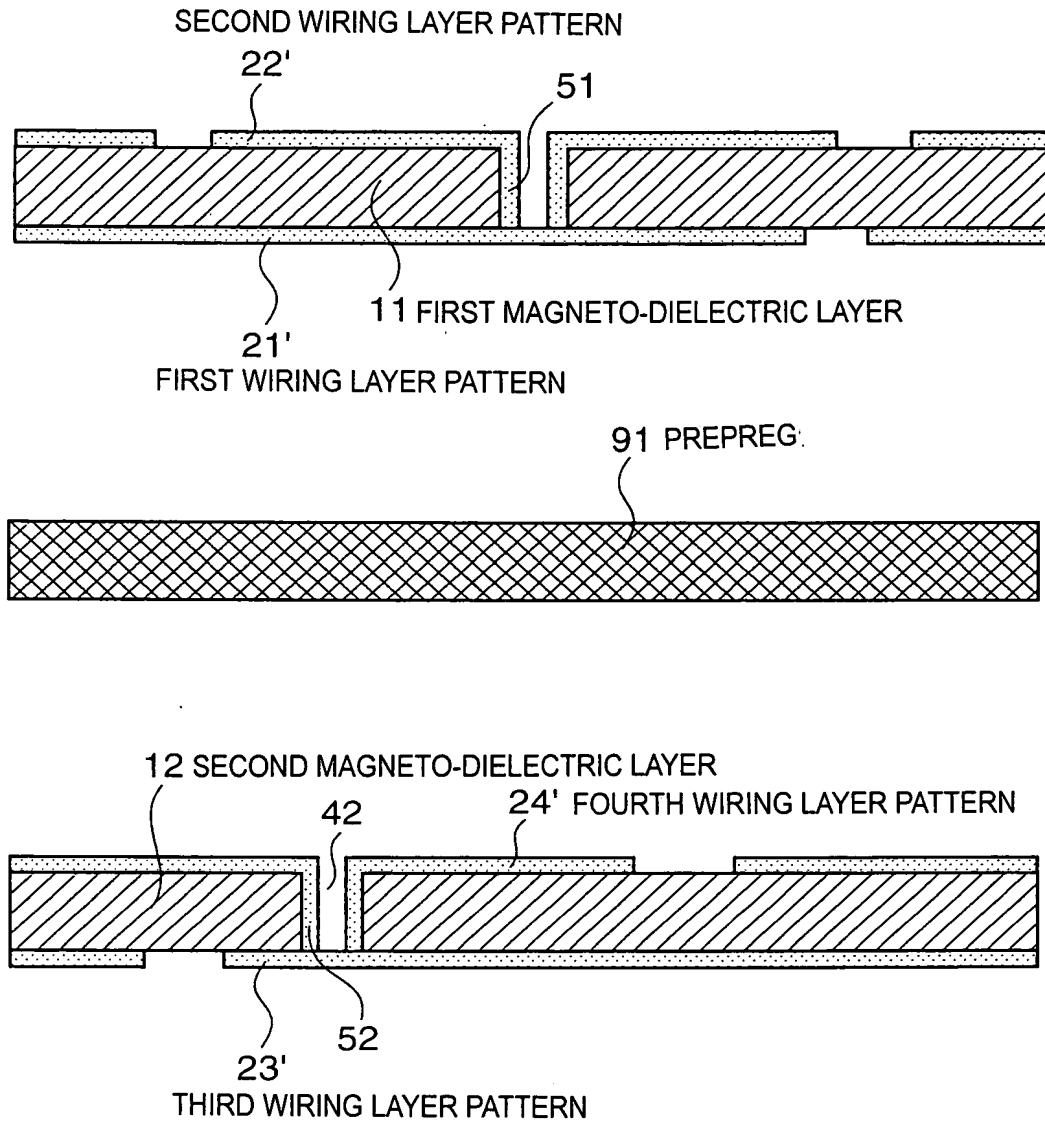


FIG. 32

**FIG. 33**

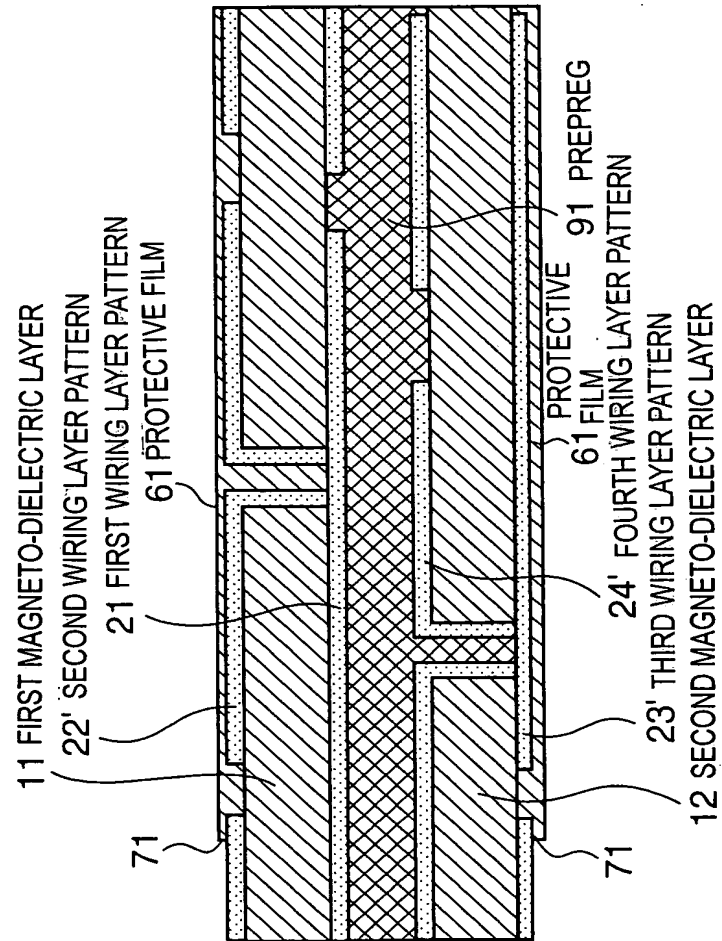


FIG. 34

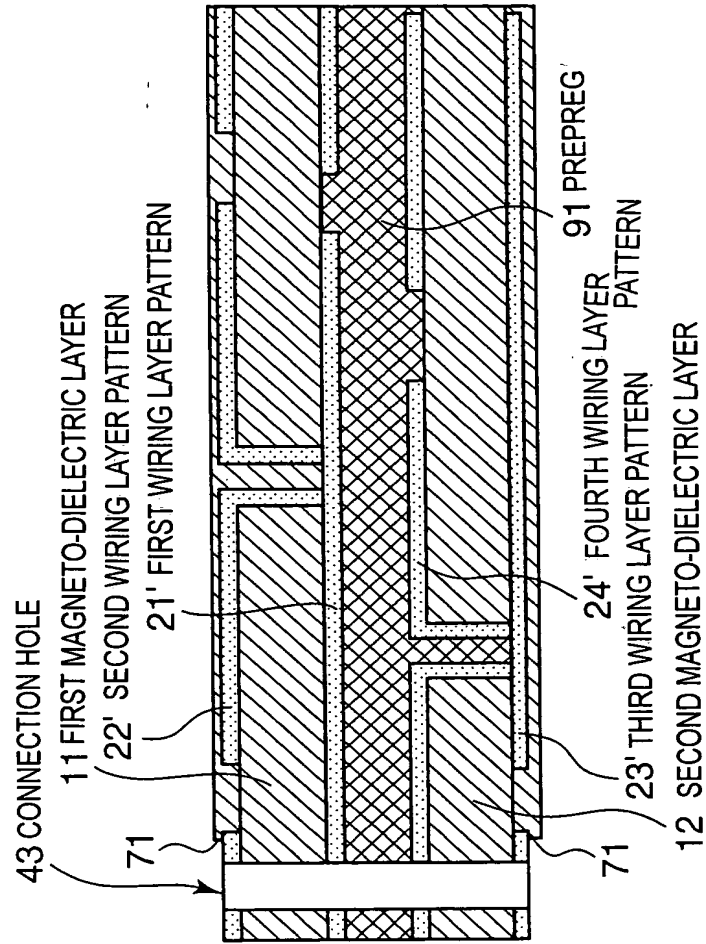
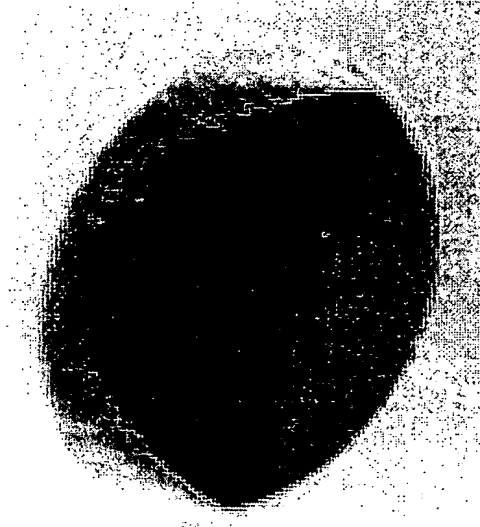


FIG. 35



GENERAL LASER PROCESSING
(CARBON DIOXIDE LASER OR THE LIKE)

FIG. 37A



EXCIMER LASER PROCESSING

FIG. 37B

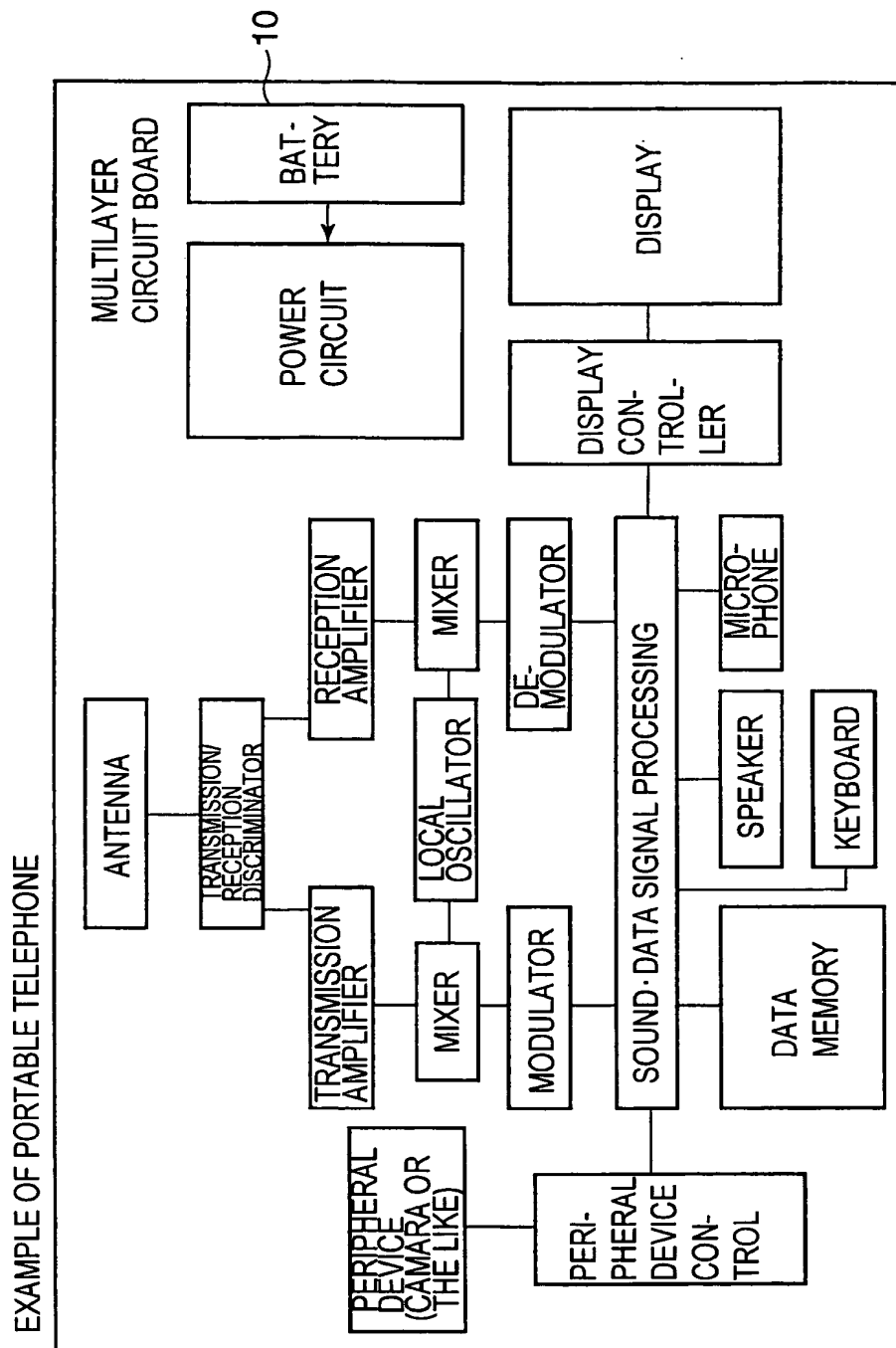


FIG. 38

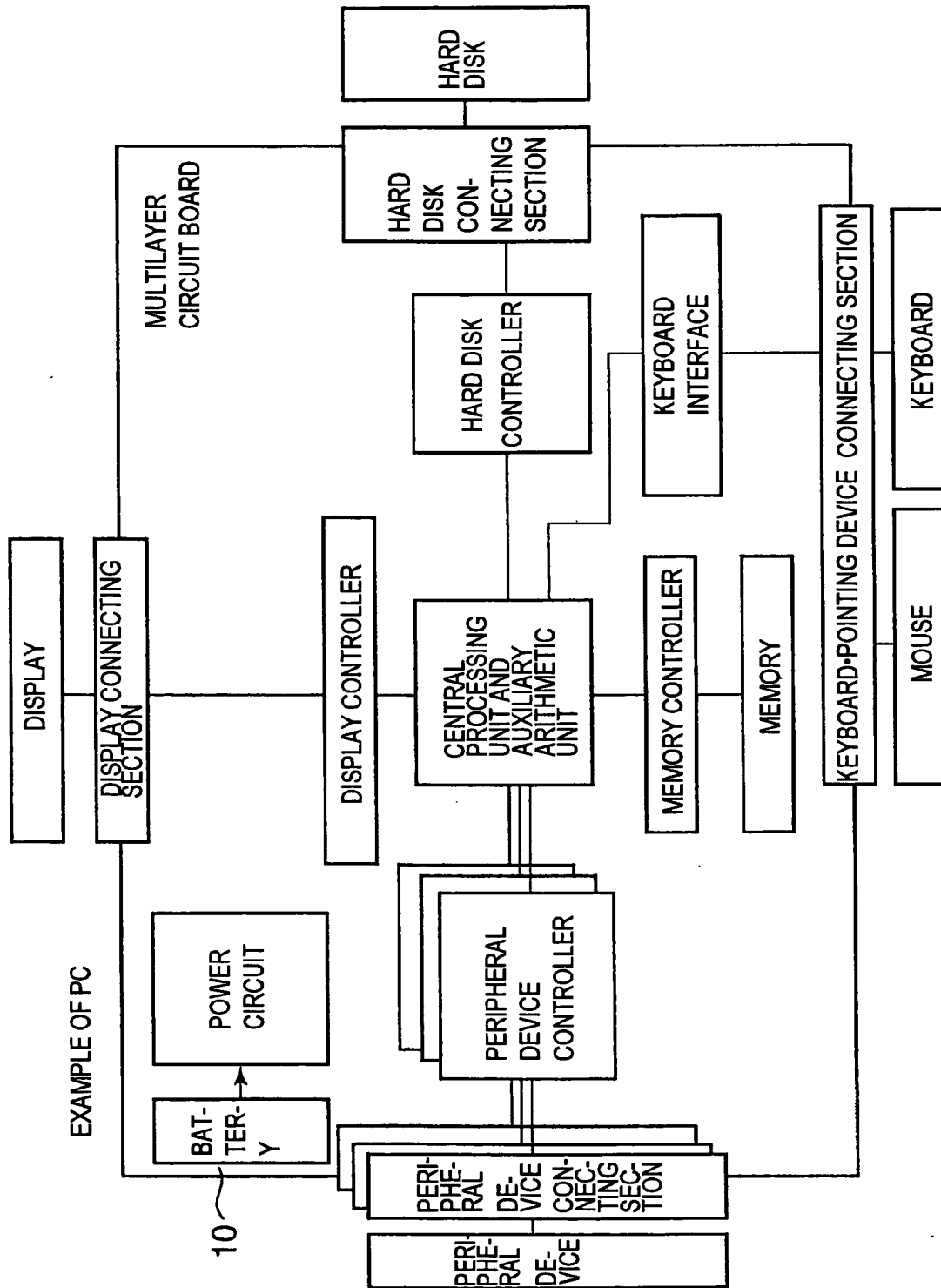


FIG. 39

12/1525329

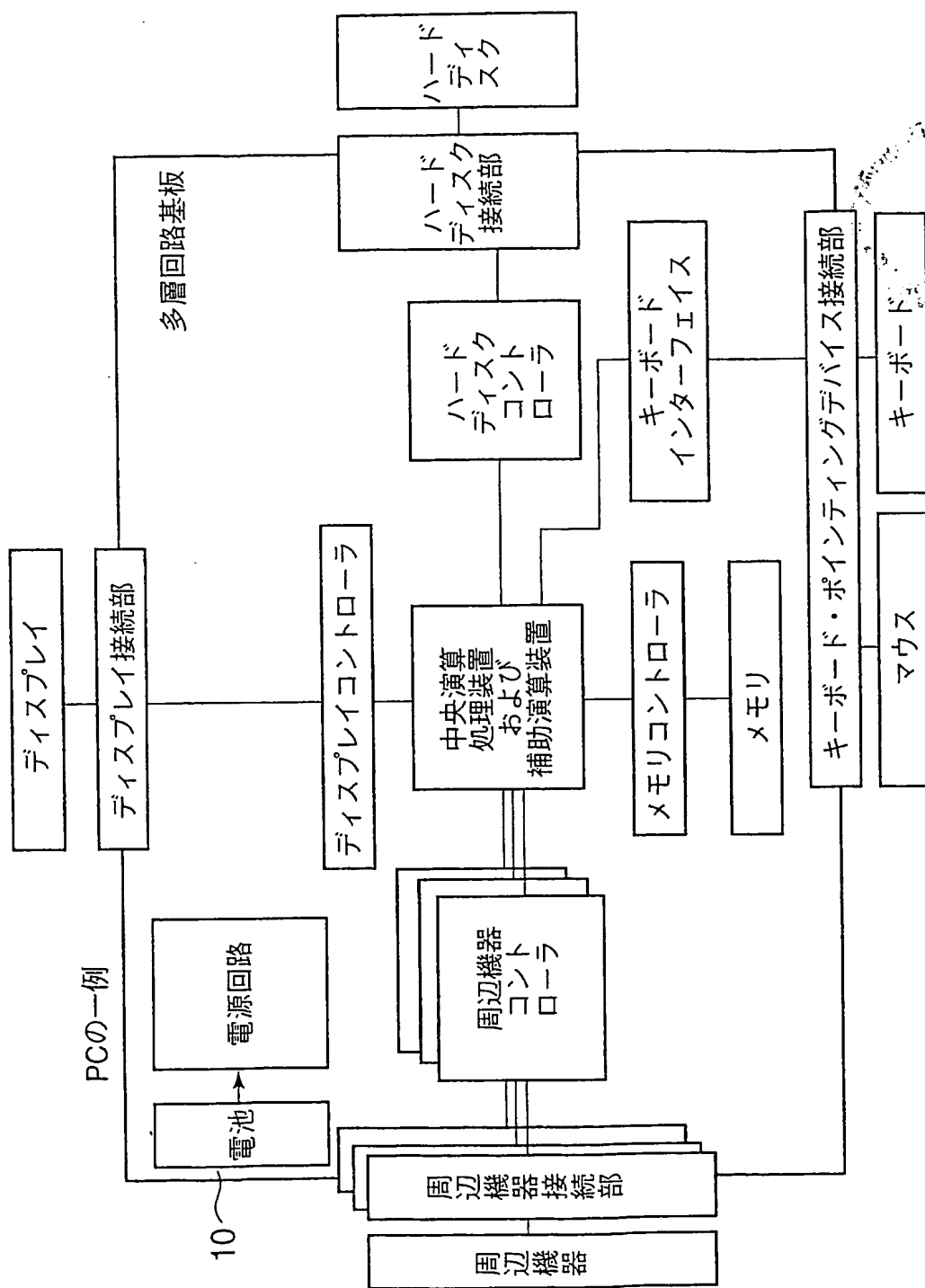


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